

Electronic Acknowledgement Receipt

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Application Number:	10525297
International Application Number:	
Confirmation Number:	6004
Title of Invention:	Process and system for laser crystallization processing of film regions on a substrate to minimize edge areas, and a structure of such film regions
First Named Inventor/Applicant Name:	James S. Im
Customer Number:	21003
Filer:	David W. Schalk
Filer Authorized By:	
Attorney Docket Number:	A35413-PCT-USA (070050.27)
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Application Type:	U.S. National Stage under 35 USC 371

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Payment Type	Deposit Account
Payment was successfully received in RAM	\$180
RAM confirmation Number	3149
Deposit Account	024377
Authorized User	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part/.zip	Pages (if appl.)

1	Information Disclosure Statement (IDS) Filed (SB/08)	NYC_ECOPY.PDF	1047288 f2607964840e6088568bd3b1e413c650160 45f34	no	17
Warnings:					
Information:					
This is not an USPTO supplied IDS fillable form					
2	Foreign Reference	F1.pdf	1277685 4efde a788e8c3e73a3e8e5d59cb19845986 33233	no	30
Warnings:					
Information:					
3	Foreign Reference	F2.pdf	694266 d93ef14066950d94225ab3f9a0c0759611b 6a0ff	no	17
Warnings:					
Information:					
4	Foreign Reference	F3.pdf	1234027 5f48264cc18abf955d019962b1bdc01cc2ae fc6d	no	28
Warnings:					
Information:					
5	Foreign Reference	F4.pdf	2089503 31a5585004c2de97491e86496d33246f196 1908d	no	49
Warnings:					
Information:					
6	Foreign Reference	F5.pdf	623576 cf3c446a66e3a398f46208b1cf34053e8bd 34cd	no	10
Warnings:					
Information:					
7	Foreign Reference	F6.pdf	1027274 9a0b057b35516f20557211b78188fd4d26f d1ed3	no	12
Warnings:					
Information:					
8	Foreign Reference	F7.pdf	355520 f4de7fd97dbc3113348078bc1e51ed9455a 99f0	no	6
Warnings:					
Information:					
9	Foreign Reference	F8.pdf	991790 f738b6df56d5aae6a5502a3bfa1a9b8013b 271f	no	14

Warnings:					
Information:					
10	Foreign Reference	F9.pdf	1007999 5d25a2926631193b1d9e11d302bf1284e70 32cc9	no	27
Warnings:					
Information:					
11	NPL Documents	N1.pdf	1239330 205ff61f51d3159e5ebb1a14c54ea966a26d c2d2	no	6
Warnings:					
Information:					
12	NPL Documents	N2.pdf	430388 12a4a678c25af000775cb94669459b6af5d 49f2	no	3
Warnings:					
Information:					
13	NPL Documents	Bergmann_Nucleation.pdf	1199645 677bba5ef544cda4748d0cc52996ce2ecda b4c81	no	16
Warnings:					
Information:					
14	NPL Documents	Biegelsen-Origin.pdf	234450 acce1846a8817fea99fa8c97b79672435a33 cda7	no	3
Warnings:					
Information:					
15	NPL Documents	Boyd_LaserProcessing.pdf	180212 5c52f306133426ac80551408ff1fe2fd49324 5c5	no	3
Warnings:					
Information:					
16	NPL Documents	Brotherton_Characterisation. pdf	297835 36a01c6a9de0d73129a14b48ba0a53c00dd b4da4	no	4
Warnings:					
Information:					
17	NPL Documents	Crowder_Parametric.pdf	713349 f726abd1cf71cd8481d62235fc8b5bd2f10 d01a	no	7
Warnings:					
Information:					
18	NPL Documents	Crowder_Sequential.pdf	511021 c39ca09d19c1aef83d0138a8b84e2f443ec8 c547	no	6

Warnings:					
Information:					
19	NPL Documents	Dassow_Laser_Crystallization.pdf	331549 bdda1512051384da5a1931c66582a73d19 31a3bf	no	4
Warnings:					
Information:					
20	NPL Documents	Dassow_Laser_Crystallized.pdf	712303 e22d2db270cc81d482d976feaf95faf82b59 7246	no	5
Warnings:					
Information:					
21	NPL Documents	Dassow_NdYVO4.pdf	527400 133e57552bc378320107b5010a933d0e650 0896e	no	6
Warnings:					
Information:					
22	NPL Documents	Dimitriadis_Effect.pdf	1044162 a3a8eecf0e9386d2e61fb2437432cd490088 4263	no	11
Warnings:					
Information:					
23	NPL Documents	Geis_Crystallographic.pdf	354241 6f674d4ae252274b66e9ba0c8d3129db2ef efbcb	no	4
Warnings:					
Information:					
24	NPL Documents	Geis_Silicon.pdf	299946 c0310ac7996547b18ddf50c95fefdb3e888b f95e	no	3
Warnings:					
Information:					
25	NPL Documents	Geis_ZoneMelting.pdf	1049546 d3cf16c6cb6f6ec79ec02eb442c2bc90b3f dfcf	no	7
Warnings:					
Information:					
26	NPL Documents	Gupta_Numerical.pdf	329916 19533ba1620299500721513a0c50217e58a 2a567	no	3
Warnings:					
Information:					
27	NPL Documents	Hawkins-Origin.pdf	319328 98184ab4252841385198d66c029823903c6 a9dc8	no	3

Warnings:					
Information:					
28	NPL Documents	Hayzelden_Silicide.pdf	2248864 6c98e17d9d417ab2ef2fce2544cbf99a5f92 b33	no	19
Warnings:					
Information:					
29	NPL Documents	Im_Provisional_Application_No _60503419.pdf	1233723 5ff60a92768a3036a16de21235b04d184b1 be5c4	no	27
Warnings:					
Information:					
30	NPL Documents	Jung_Dependence.pdf	439783 01f1c7ef84e2a53ec74561db1b61758d673 97a8d	no	6
Warnings:					
Information:					
31	NPL Documents	Kahlert_Creating.pdf	975631 e7a7e5c00f682cfde31ef09d8/b20996eaef 1731	no	3
Warnings:					
Information:					
32	NPL Documents	Kim_Development.pdf	443838 2bea154e058/c9223e5cc0af475f1e9a1d04 dfc8	no	4
Warnings:					
Information:					
33	NPL Documents	Kim_Effects.pdf	1804802 87926c93e0f75b01b3b4e841f1e5eb6e6b1 e2fb3	no	22
Warnings:					
Information:					
34	NPL Documents	Kim_Excimer_Laser.pdf	337944 45ce8e04a35d3a50da56234b0da656891e1 e0c65	no	6
Warnings:					
Information:					
35	NPL Documents	Kim_Multiple.pdf	527284 1ac40483faf3ed567c154a4194078d77239b 26fe	no	6
Warnings:					
Information:					
36	NPL Documents	Kim_NewExcimer.pdf	355925 2f5b3910fc4fabeebee7acf2ae28e6fdbe716 503	no	3

Warnings:					
Information:					
37	NPL Documents	Kimura_Influence.pdf	287504 87d1afbbea5f9d735b7be83d83316eb067 34d26	no	3
Warnings:					
Information:					
38	NPL Documents	Knowles_P_59.pdf	363697 b775e8529c01716c956b34209b2ce7d31db 7561b	no	3
Warnings:					
Information:					
39	NPL Documents	Kohler_Large_Grained.pdf	759027 4ac69d893f0ce4c6e059b5fde0e7e165ebb d356b	no	9
Warnings:					
Information:					
40	NPL Documents	Kung_Implant_Dose.pdf	993822 df44aea6164424bb3bc04b8dd69efacacd5 cec9c	no	8
Warnings:					
Information:					
41	NPL Documents	Jung_Low_Temp.pdf	515301 4a612031ab67399b7dbd434e51c84b558fc 1a558	no	6
Warnings:					
Information:					
42	NPL Documents	Kung_Seed.pdf	1022664 cea1f717ec2f3fb80e74c22460191cae04 206	no	10
Warnings:					
Information:					
43	NPL Documents	Kuriyama_Comprehensive.pdf	1475504 b987cec37e73997cc8e2596ffab61efef9e62 438	no	14
Warnings:					
Information:					
44	NPL Documents	Kuriyama_Lateral.pdf	1463603 7a903449876afb9bde99c58a700b29f2cb0 80ab5	no	14
Warnings:					
Information:					
45	NPL Documents	Lee_Low_Temp.pdf	1028029 9e218adebded6d991e2477f68accc4d2354 6954d	no	10

Warnings:					
Information:					
46	NPL Documents	Lee_Pd.pdf	1263616 16d48a820c8a504516149cec121699d2044 e55a0	no	10
Warnings:					
Information:					
47	NPL Documents	Leonard_Stochastic.pdf	294664 2a96dfaface01a54601ef2c8d42ddf75dbc8 beed	no	3
Warnings:					
Information:					
48	NPL Documents	Limanov_Development.pdf	517760 d4f0e3a88c95bfe75474178a2f47e28d6944 78a8	no	7
Warnings:					
Information:					
49	NPL Documents	Limanov_Single_Axis.pdf	1245726 8a74a7c791c4799463b3a56f58df4a716de4 f5b8	no	12
Warnings:					
Information:					
50	NPL Documents	Limanov_Study.pdf	1005703 16fcdb4f682110b3def67d33f2461835ee09 0f64	no	10
Warnings:					
Information:					
51	NPL Documents	MicroLasLasersystem_UVOptics .pdf	1201734 00fd7d871501d5b4b57d337ffcc8d15d30da c31f	no	12
Warnings:					
Information:					
52	NPL Documents	Miyasaka_In_situ.pdf	1139399 59c450c5d003e3976297ab44915bc964bfa 8c65d	no	10
Warnings:					
Information:					
53	NPL Documents	Nerding_Tailoring.pdf	1195921 38bef8e1c664098a17723283748c0f5bd96e f6a5	no	14
Warnings:					
Information:					
54	NPL Documents	Sato_Mobility.pdf	1202821 1035cc9dbb7b99096ae14aa4aaff5aaaf3d1f9 3b4	no	11

Warnings:					
Information:					
55	NPL Documents	Smith_Mechanism.pdf	1021945 82452ff992823be24a12fa8dbaade46f80ba1 a822	no	4
Warnings:					
Information:					
56	NPL Documents	Song_SingleCrystal.pdf	394251 ef01fce9e8ad672591291d07bb95bc9e254 114d0	no	3
Warnings:					
Information:					
57	Fee Worksheet (PTO-875)	fee-info.pdf	30394 924432a0761b836717ac3a321acf7c6ac992 d652	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			46914428		
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